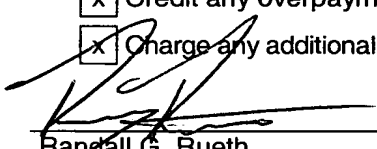
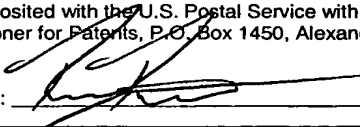
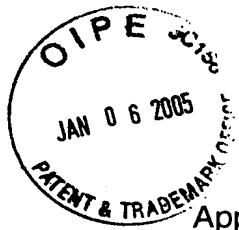


AF EFW

AMENDMENT TRANSMITTAL LETTER				Docket No. 30521/071	
Application No. 09/910,110-Conf. #1681		Filing Date July 20, 2001		Examiner H. D. Le	
				Art Unit 2643	
Applicant(s): Peter V. Loeppert et al.					
Invention: RAISED MICROSTRUCTURE OF SILICON BASED DEVICE					
<b>TO THE COMMISSIONER FOR PATENTS</b>					
Transmitted herewith is an amendment after final in the above-identified application. The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	23	- 23 =		X	
Independent Claims	3	- 3 =		X	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>13-2855</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 Randall G. Rueth Attorney Reg. No.: 45,887				Dated: <u>January 3, 2005</u>	
MARSHALL, GERSTEIN & BORUN LLP 233 S. Wacker Drive, Suite 6300 Sears Tower Chicago, Illinois 60606-6357 (312) 474-6300					
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.					
Dated: January 3, 2005		Signature:  (Randall G. Rueth)			



**IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE**

Applicant: LOEPPERT ET AL.

Serial No.: 09/910,110

Filed: JULY 20, 2001


Title: RAISED MICROSTRUCTURE OF  
SILICON BASED DEVICE

Group Art Unit: 2643

Examiner: HUYEN D. LE

) I hereby certify that this paper is being  
) deposited with the United States Postal  
) Service as first class mail, postage  
) prepaid, in an envelope addressed to:

) Mail Stop AF  
) Commissioner for Patents  
) P.O. Box 1450  
) Alexandria, VA 22313-1450,  
) on **January 3, 2005**.

)   
) \_\_\_\_\_  
) Randall G. Rueth  
) Reg. No. 45,887

**AFTER FINAL RESPONSE TO THE ACTION  
DATED NOVEMBER 3, 2004**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This amendment is submitted in response to the Final action dated November 3, 2004. Applicants respectfully request reconsideration of the application in view of the following amendments and remarks.

**Status of the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.